

# **ELECTRONIC COPY**

### LABORATORY GROWN DIAMOND REPORT

July 25, 2024

IGI Report Number LG645454648

Description LABORATORY GROWN DIAMOND

Shape and Cutting Style EMERALD CUT

Measurements 12.10 X 8.53 X 5.83 MM

**GRADING RESULTS** 

Carat Weight 5.85 CARATS

Color Grade

Clarity Grade VS 1

## ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT** 

Symmetry **EXCELLENT** 

Fluorescence NONE

Inscription(s) (3) LG645454648

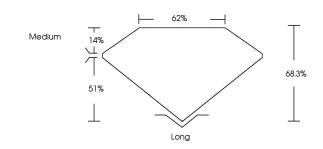
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth

process. Type IIa

## LG645454648

Report verification at igi.org

### **PROPORTIONS**

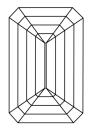




Sample Image Used

#### **CLARITY CHARACTERISTICS**





### **KEY TO SYMBOLS**

Red symbols indicate internal characteristics. Green symbols indicate external characteristics.

### COLOR

| D E F                  | G H I J                        | Faint                     | Very Light           | Light    |
|------------------------|--------------------------------|---------------------------|----------------------|----------|
|                        |                                |                           | 7                    |          |
| CLARITY                |                                |                           |                      |          |
| IF                     | WS <sup>1 - 2</sup>            | VS <sup>1-2</sup>         | SI 1-2               | I 1-3    |
| Internally<br>Flawless | Very Very<br>Slightly Included | Very<br>Slightly Included | Slightly<br>Included | Included |



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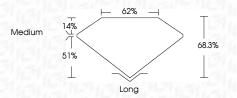
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